## Notice of References Cited Application/Control No. 10/605,140 Examiner Kim Huynh Applicant(s)/Patent Under Reexamination CHOU ET AL. Art Unit Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,507,881	01-2003	Chen, Joe	710/305
	В	US-5,872,994	02-1999	Akiyama et al.	712/43
	С	US-6,708,257	03-2004	Bao, Liewei	711/154
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	Н	US-			
	l	US-			
	J	US-			-
	Κ	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	S					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	х	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.